

FIG. 1 is a schematic diagram of a system for detecting a light source. The system includes a light source 125, a lens 115, a detector array 110, and a control unit 105. The light source 125 emits light rays that pass through the lens 115 and are focused onto the detector array 110. The control unit 105 is connected to the detector array 110 and processes the detected light signals.

LIGHT SOURCE 125

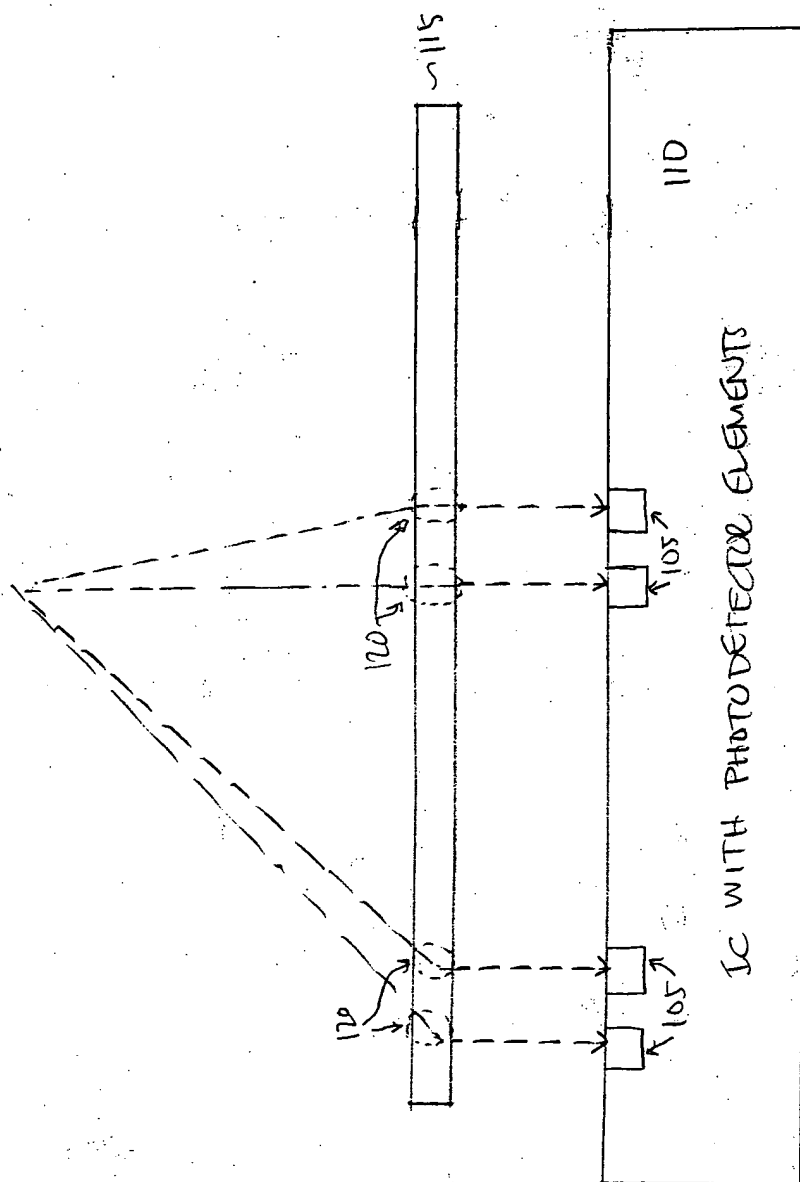


FIGURE 1

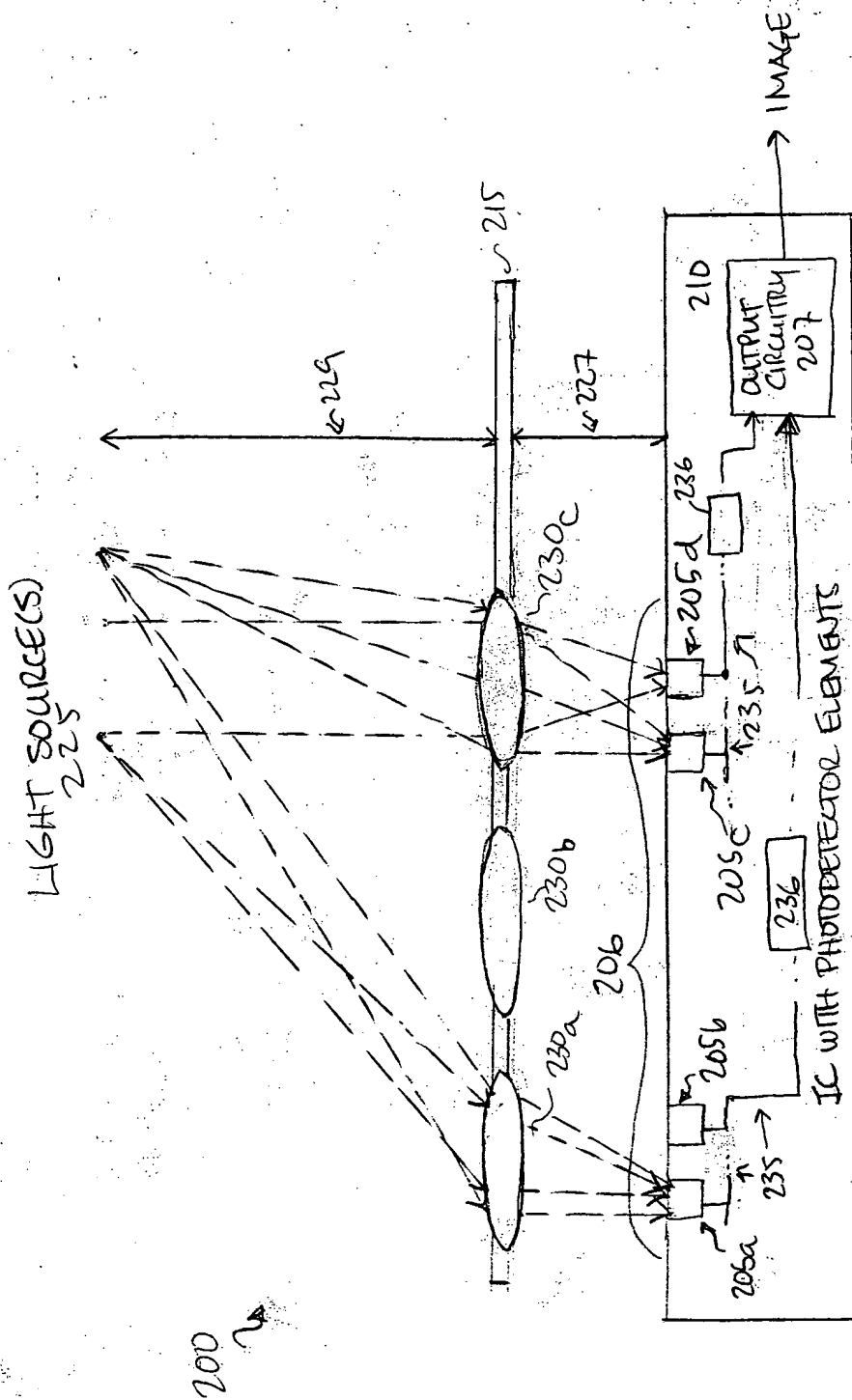
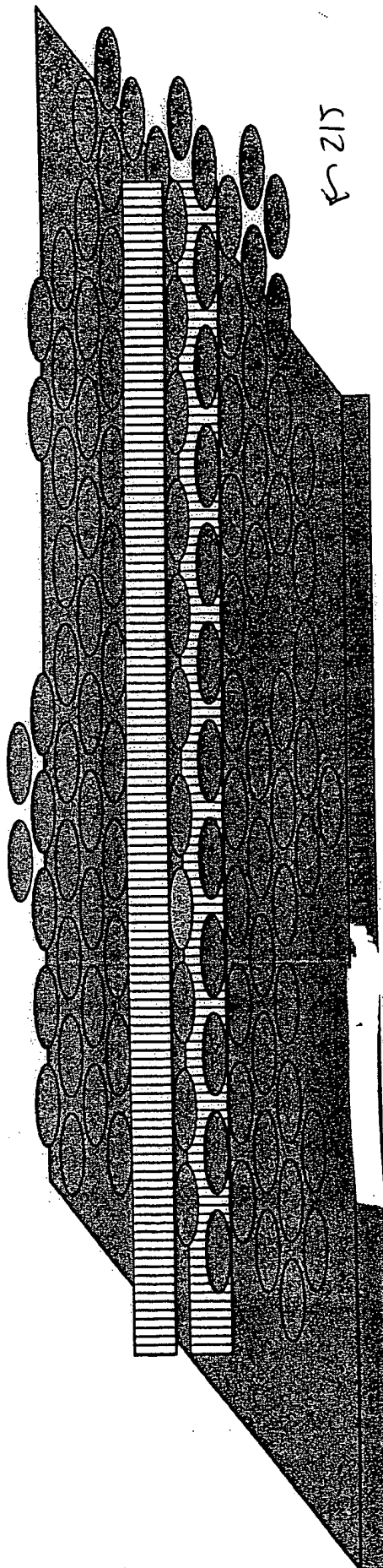


FIGURE 2

1. The present invention relates to a method of fabricating a semiconductor device, and more particularly to a method of fabricating a semiconductor device having a photodecode circuit.



IC WITH PHOTODECODE CIRCUITS

FIGURE 3

- LIGHT SOURCE(S)
415

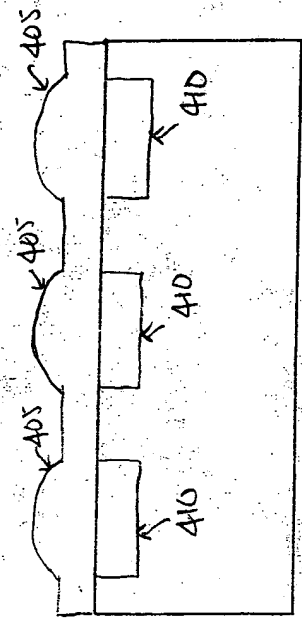
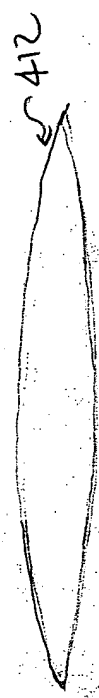


FIGURE 4
(PRIOR ART)

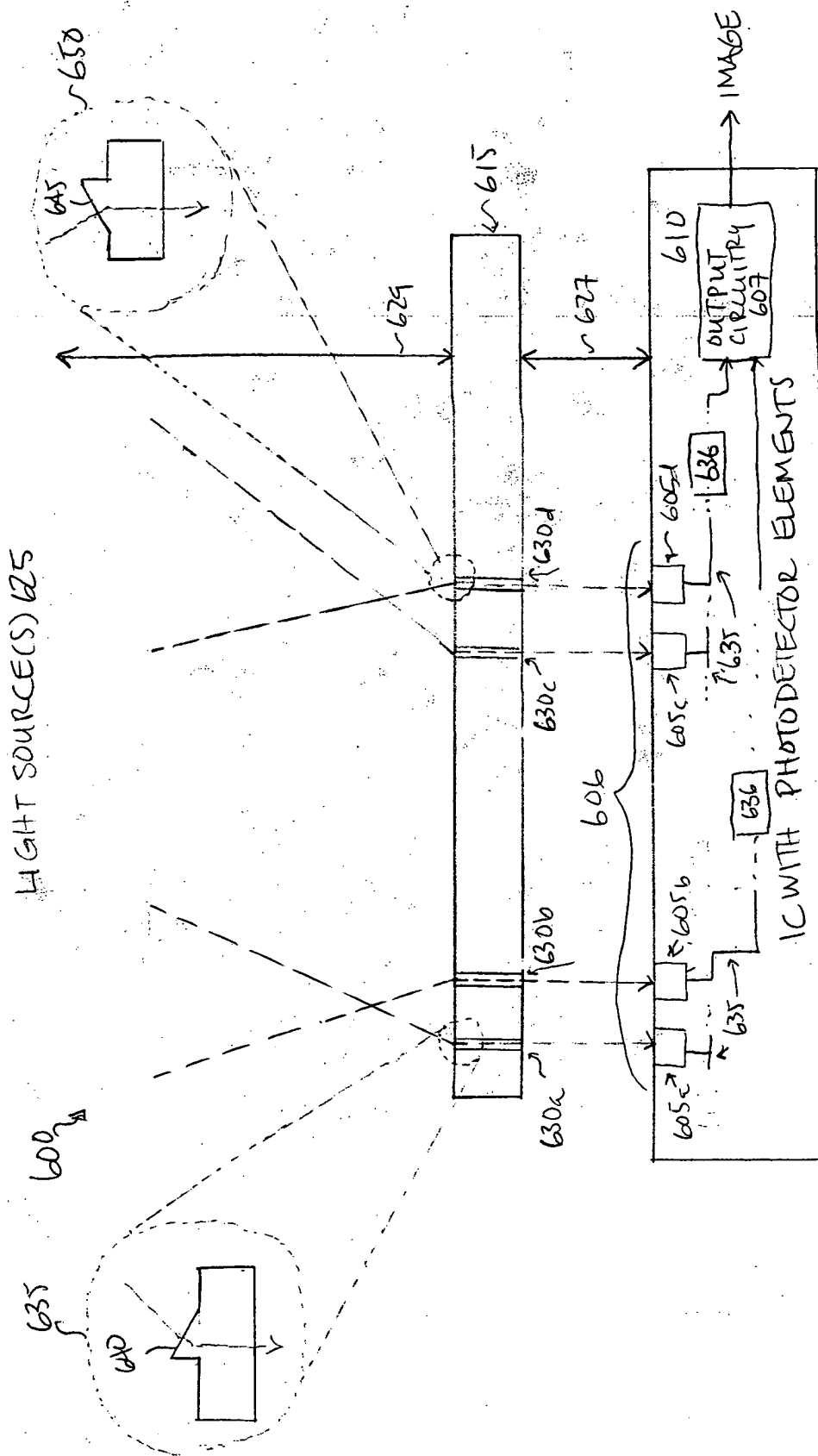


FIGURE 6

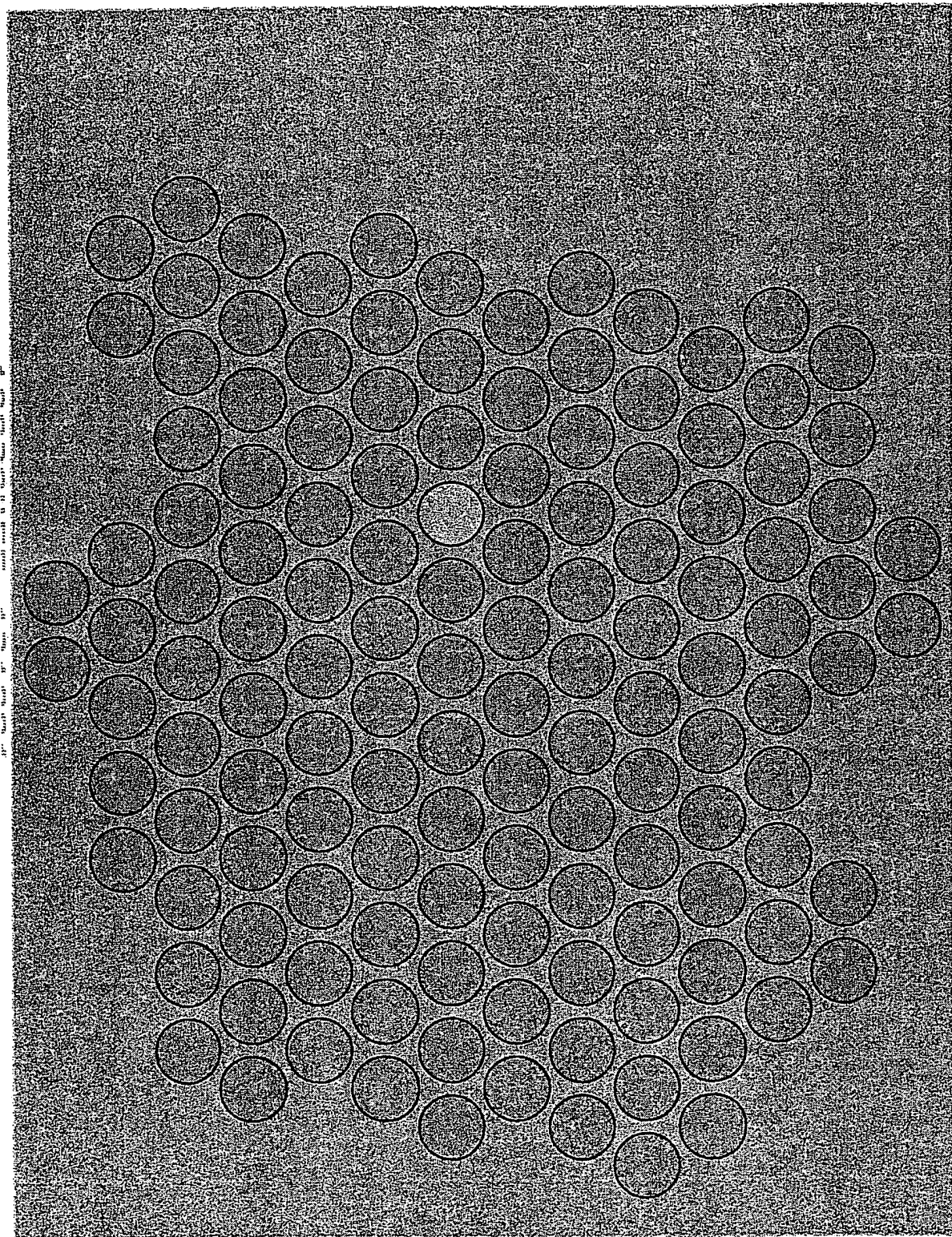


Figure 7

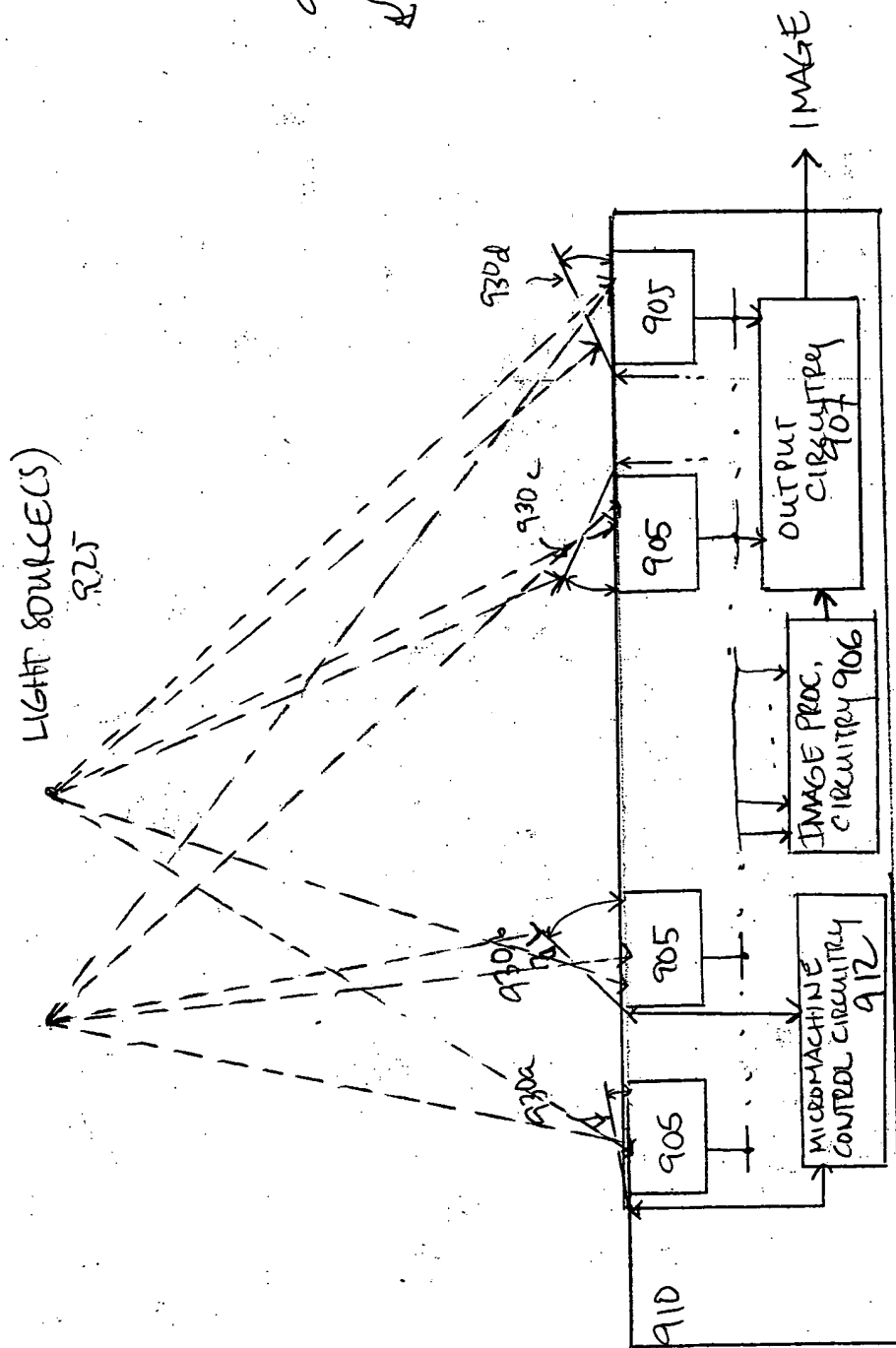


Figure 9

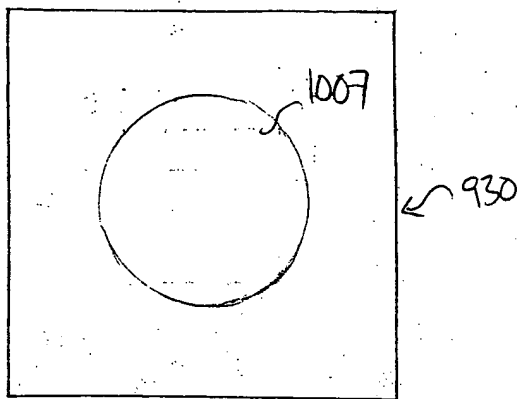


FIGURE 10

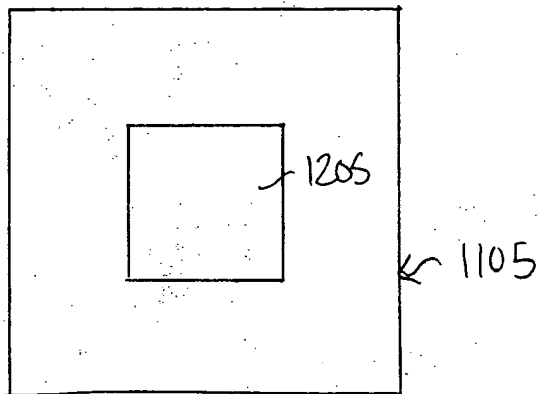


FIGURE 12

FIG. 11 is a block diagram of a system for processing an image of a scene. The system includes a light source 1125, a lens 1106, a sensor array 1110, and a processing unit 1107. The light source 1125 emits light 1125(a) which is focused by the lens 1106 onto the sensor array 1110. The sensor array 1110 is divided into a grid of elements 1105a, 1105b, 1105c, 1105d, 1105e, and 1105f. The processing unit 1107 receives data from the sensor array 1110 and outputs a processed image 1106.

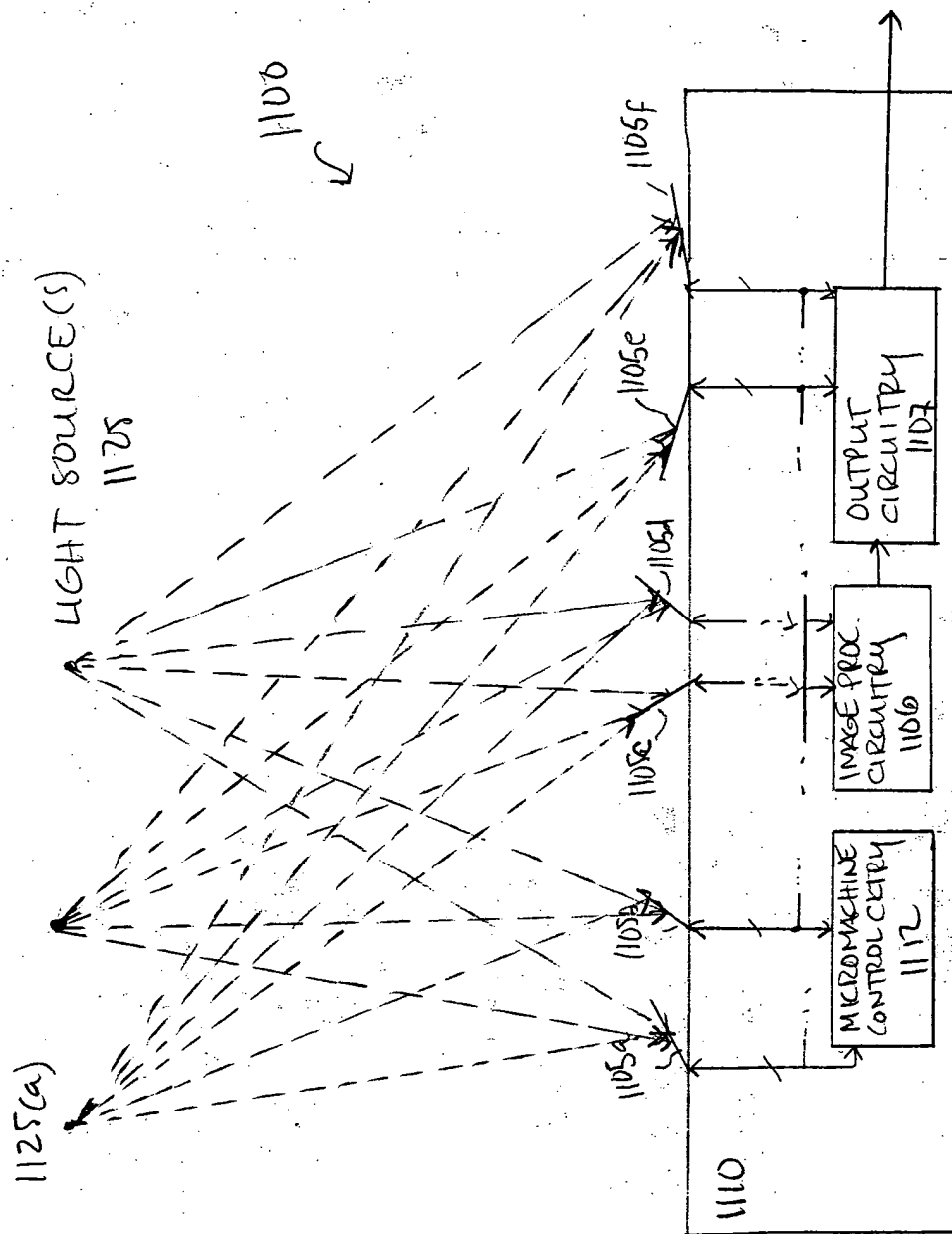


FIGURE 11

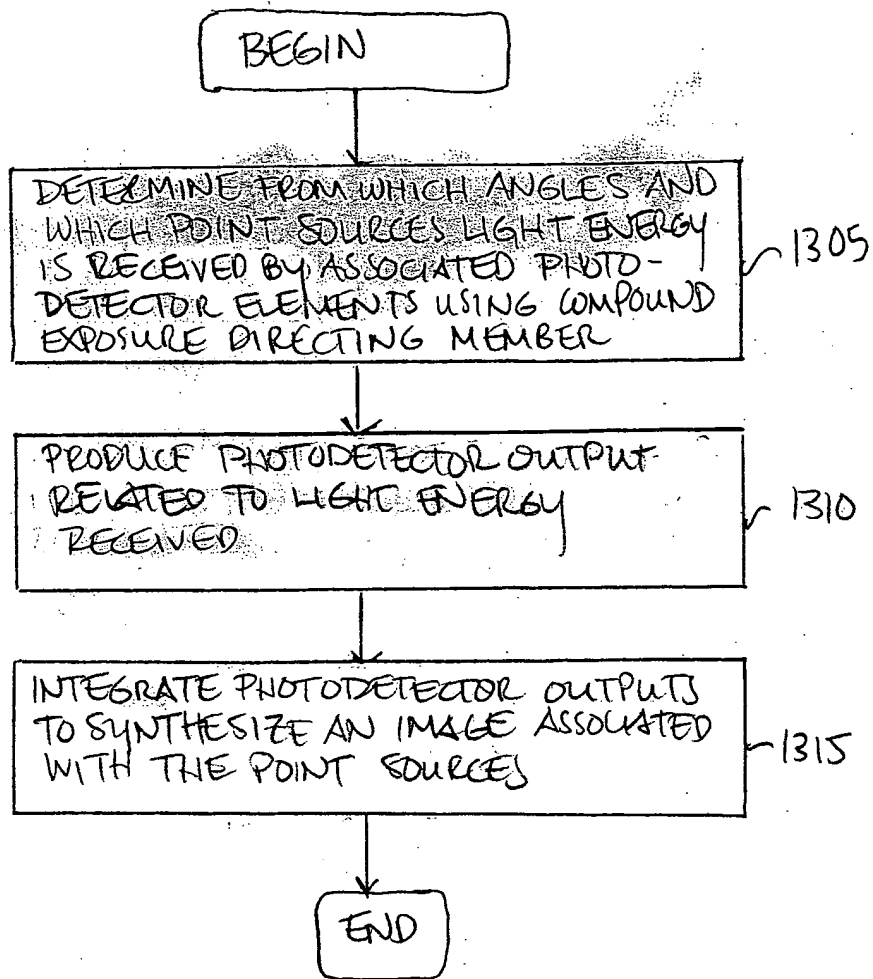


FIGURE 13